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## APPLICANTS

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Yi-Nan Chen, Taipei, TAIWAN;\*\* CONTINUING DATA \*\*\*\*\* *Lee**NONE*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Lee**NONE*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 4	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>Lee</i> Initials				

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## TITLE

Method for forming shallow trench in semiconductor device

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